| Electronic Patent Application Fee Transmittal | | | | | | | |
|-----------------------------------------------|-------------------------------------------------------------------------------------|----------|--------|-------------------------|--|--|--|
| Application Number: | 10813834 | | | | | | |
| Filing Date: | 31-Mar-2004 | | | | | | |
| Title of Invention: | Method And Program For Correcting And Testing Mask Pattern Optical Proximity Effect | | | | | | |
| First Named Inventor/Applicant Name: | Keiichiro Tounai | | | | | | |
| Filer: | Norman P. Soloway | | | | | | |
| Attorney Docket Number: | NEC A433 | | | | | | |
| Filed as Large Entity | | | | | | | |
| Utility under 35 USC 111(a) Filing Fees | | | | | | | |
| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) | | | |
| Basic Filing: | • | | | | | | |
| Pages: | | | | | | | |
| Claims: | | | | | | | |
| Miscellaneous-Filing: | | | | | | | |
| Petition: | | | | | | | |
| Patent-Appeals-and-Interference: | | | | | | | |
| Post-Allowance-and-Post-Issuance: | | | | | | | |
| Extension-of-Time: | | | | | | | |

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|-----------------------------------|-------------------|----------|--------|-------------------------|
| Miscellaneous: | | | | |
| Request for continued examination | 1801 | 1 | 810 | 810 |
| | Total in USD (\$) | | | 810 |